Docket No.

250132US-2TTCRD DIV

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Shiho OKUNO, et al.

SERIAL NO: New DIV Application GAU:

FILED:

Herewith

EXAMINER:

FOR:

MAGNETORESISTANCE EFFECT ELEMENT, ITS MANUFACTURING METHOD, MAGNETIC

REPRODUCING ELEMENT AND MAGNETIC MEMORY

INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.97

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

SIR-

Applicant(s) wish to disclose the following information.

REFERENCES

- The applicant(s) wish to make of record the references listed on the attached form PTO-1449 which were cited and submitted in Serial No. 10/244,550 filed 09/17/02, where required, as are either statements of relevancy or any readily available English translations of pertinent portions of any non-English language references.
- A check or credit card payment form is attached in the amount required under 37 CFR §1.17(p).

RELATED CASES

- Attached is a list of applicant's pending application(s) or issued patent(s) which may be related to the present application. A copy of the patent(s), together with a copy of the claims and drawings of the pending application(s) is attached along with PTO 1449.
- ☐ A check or credit card payment form is attached in the amount required under 37 CFR §1.17(p).

CERTIFICATION

- ☐ Each item of information contained in this information disclosure statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement.
- □ No item of information contained in this information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application or, to the knowledge of the undersigned, having made reasonable inquiry, was known to any individual designated in 37 CFR §1.56(c) more than three months prior to the filing of this statement.

DEPOSIT ACCOUNT

Please charge any additional fees for the papers being filed herewith and for which no check or credit card payment is enclosed herewith, or credit any overpayment to deposit account number 15-0030. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

OBLON, SPIVAK, McCDBLL AIER & MEU İSTADTA

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Form PTO 1449 (Modified)		U.S. DEPARTMENT PATENT AND TRAD	OF COMMERCE	ATTY DOCKET NO.		SERIAL NO.			
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				APPLICANT					
LIST OF	REFE	RENCES CITED BY AP	PLICANT	Shiho OKUNO, et al.					
				FILING DATE		GROUP			
				Herewith					
U.S. PATENT DOCUMENTS									
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB FILING DATE CLASS IF APPROPRIATE			
	AA	6,469,926	10-2002	Chen, Eugene Youjun					
	AB	2001/0009063	07/2001	Saito et al.					
	AC	2002/0051380	05/2002	Kamiguchi et al.					
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FOREIGN PATENT DOCUMENTS									
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	AP								
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	AS					-			
	AT								
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OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)									
N. GARCIA, et al., "Magnetoresistance in Excess of 200% in Ballistic Ni Nanocontacts at Room Temperature and 100 Oe,"									
	AW	PHYSICAL REVIEW LETTERS, Vol. 82, No. 14, April 5, 1999, pp. 2923-2926							
	AX	J.J. VERSLUIJS, et al., "Magnetoresistance of Half-Metallic Oxide Nanocontacts," PHYSICAL REVIEW LETTERS, Vol. 87, No. 2, July 9, 2001, pp. 026601-1 through 026601-4							
	AY								
	AZ				Additional References sheet(s) attached				
Examiner					Date Cor	Date Considered			
*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.									
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